

KNF LAB PUMPS AND SYSTEMS. KNOWING WHAT COUNTS.





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KNF LAB PUMPS AND SYSTEMS. COMPELLING ADVANTAGES.

KNF permanently strives to counter the challenges of daily lab work with easy handling. Devices from KNF are therefore intuitive and compact, and offer clear advantages when it comes to intelligent functions: quiet operation, powerful and totally reliable.

Discover lab technology that supports you.

ROTARY EVAPORATION / DISTILLATION. REPRODUCIBLE RESULTS WITH SHORT PROCESSING TIMES.



reddot award 2014
winner

RC 900 Rotary Evaporator

- Sleek design, minimum footprint
- Whisper quiet for a pleasant working environment
- Versatile use, simple operation

Cooling condenser is **straight-forward to detach** by turning the clamping nut. The cooling condenser is also extremely easy to clean.

Relevant parameters for distillation and for the heating bath are easily set by **touching and turning**.

Cordless heating bath with pour spout for **safe emptying without spilling**.



The RC 900 rotary evaporator can be teamed with the SC 920 vacuum pump system and the C 900 chiller to create a precisely tuned system.



SC 920

QUIET

SC 920 and SC 950 Vacuum Pump System

- Flow rate up to 3 m³/h / Ultimate vacuum 2 mbar abs.
- Remote-controlled for safe operation from outside closed fume hoods
- Automated, precise boiling point recognition and control
- Speed-controlled



SC 950

LABOPORT®



ROBUST

SC 820 and SC 840 Vacuum System

- Flow rate up to 2.04 m³/h / Ultimate vacuum 8 mbar abs.
- Vacuum system comprising chemically resistant diaphragm vacuum pump, base plate, condenser, separator and vacuum control unit

LABOPORT®



CHEMICALLY RESISTANT

N 820.3 FT.18, N 840.3 FT.18 and N 842.3 FT.18 Diaphragm Vacuum Pump

- Flow rate up to 2.04 m³/h / Ultimate vacuum up to 2 mbar abs.
- High level of vapor and condensate compatibility
- PTFE pump head combined with PTFE-coated diaphragm are ideal for extremely aggressive/corrosive gases and vapors

SPEED-CONTROLLED

N 920 KT.29.18 Diaphragm Vacuum Pump

- Flow rate 1.2 m³/h / Ultimate vacuum 2 mbar abs.
- High suction speed, particularly in the low vacuum range
- Integrated rotational speed control enables pumping capacity to be easily adapted to process requirements
- PPS pump head combined with PTFE-coated diaphragm are ideal for aggressive/corrosive gases and vapors



A POWERFUL PACKAGE

N 860.3 FT.40.18 Diaphragm Vacuum Pump

- Flow rate 3.6 m³/h / Ultimate vacuum 4 mbar abs.
- Integrated KNF self-drying system ensures that condensate is quickly removed from the pump heads without the vacuum being altered – processing times are markedly reduced as a result
- Chemically resistant and thus ideal for use with extremely aggressive/corrosive gases and vapors



ECONOMICAL

C 900 Chiller

- Operating temperature range -10 to +40 °C, cooling capacity 250 W
- Compact design, small footprint
- Splash-proof membrane keypad
- Easy to fill



DEGASSING. CONSTANT VACUUM FOR CLEAR RESULTS.



LABOPORT®



HIGH-PERFORMANCE

N 816.3 KT.18 Mini Diaphragm Vacuum Pump

- Flow rate 0.96 m³/h / Ultimate vacuum 20 mbar abs.
- PTFE-coated diaphragm is ideal for aggressive/corrosive gases and vapors

LABOPORT®



FAST

N 938.50 KT.18 Mini Diaphragm Vacuum Pump

- Flow rate 1.8 m³/h / Ultimate vacuum 15 mbar abs.
- Connecting both pump heads in parallel and in series ensures exceptionally fast evacuation
- PTFE-coated diaphragm is ideal for aggressive/corrosive gases and vapors

LABOPORT®



CHEMICALLY RESISTANT

N 820.3 FT.18 Diaphragm Vacuum Pump

- Flow rate 1.2 m³/h / Ultimate vacuum 8 mbar abs.
- High level of vapor and condensate compatibility
- PTFE pump head combined with PTFE-coated diaphragm are ideal for extremely aggressive/corrosive gases and vapors

SPEED-CONTROLLED

N 920 KT.29.18 Diaphragm Vacuum Pump

- Flow rate 1.2 m³/h / Ultimate vacuum 2 mbar abs.
- High suction speed, particularly in the low vacuum range
- Integrated rotational speed control enables pumping capacity to be easily adapted to process requirements
- PPS pump head combined with PTFE-coated diaphragm are ideal for aggressive/corrosive gases and vapors





**FILTRATION / SPE. RELIABLE VACUUM
FOR CLEAN RESULTS.
COMPACT, POWERFUL, FAST.**

LABOPORT®



SMALL AND FOR (ALMOST) ANY USE

N 86 KT.18 Mini Diaphragm Vacuum Pump

- Flow rate 0.33 m³/h / Ultimate vacuum 160 mbar abs.
- Extremely low footprint
- PTFE-coated diaphragm is ideal for aggressive/corrosive gases and vapors

LABOPORT®



HIGH-PERFORMANCE

N 816.3 KT.18 and N 816.1.2 KT.18 Mini Diaphragm Vacuum Pump

- Flow rate up to 1.8 m³/h / Ultimate vacuum up to 20 mbar abs.
- PTFE-coated diaphragm is ideal for aggressive/corrosive gases and vapors



LABOPORT®



FAST

N 938.50 KT.18 Mini Diaphragm Vacuum Pump

- Flow rate 1.8 m³/h / Ultimate vacuum 15 mbar abs.
- Connecting both pump heads in parallel and in series ensures exceptionally fast evacuation
- PTFE-coated diaphragm is ideal for aggressive/corrosive gases and vapors

LABOPORT®



CHEMICALLY RESISTANT

N 840.3 FT.18 Diaphragm Vacuum Pump

- Flow rate 2.04 m³/h / Ultimate vacuum 8 mbar abs.
- High level of vapor and condensate compatibility
- PTFE pump head combined with PTFE-coated diaphragm are ideal for extremely aggressive/corrosive gases and vapors

FLUID ASPIRATION. RELIABLE VACUUM WITH PROCESS-SPECIFIC FLOW RATES.

LABOPORT®



SMALL AND FOR (ALMOST) ANY USE

N 86 KT.18 Mini Diaphragm Vacuum Pump

- Flow rate 0.33 m³/h / Ultimate vacuum 160 mbar abs.
- Extremely low footprint
- PTFE-coated diaphragm is ideal for aggressive/corrosive gases and vapors

LABOPORT®



HIGH-PERFORMANCE

N 816.3 KT.18 Mini Diaphragm Vacuum Pump

- Flow rate 0.96 m³/h / Ultimate vacuum 20 mbar abs.
- PTFE-coated diaphragm is ideal for aggressive/corrosive gases and vapors

LABOPORT®



CHEMICALLY RESISTANT

N 810.3 FT.18 Diaphragm Vacuum Pump

- Flow rate 0.6 m³/h / Ultimate vacuum 8 mbar abs.
- PTFE pump head combined with PTFE-coated diaphragm are ideal for extremely aggressive/corrosive gases and vapors



METERING AND TRANSFERRING LIQUIDS.
PRECISE, SAFE AND CLEAN HANDLING OF
NEUTRAL AND AGGRESSIVE LIQUIDS.

LIQUIPORT®



RELIABLE

NF 100 and NF 300 Chemically-resistant Diaphragm Liquid Pump

- Flow rate from 0.2 up to 3 l/min / Pressure head 10 mWg, suction head 3 mWg
- Self priming, dry running
- Pump heads available in your choice of PP, PVDF or PTFE – diaphragms available in PTFE, valves in FFKM
- Pressure head also available for 60 mWg on request
- Flow rate can either be set manually (Version S) or both manually and via an external control device (Version RC)

SIMDOS®



PRECISE

SIMDOS® 02 and SIMDOS® 10 Chemically-resistant Diaphragm Dosing Pump

- Flow rate 0.03 up to 100 ml/min / Pressure head 60 mWg, suction head 2 mWg and 3 mWg respectively
- Pump heads available in your choice of PP, PVDF or PTFE – diaphragms available in PTFE, valves in FFKM
- Flow rate can either be set manually (Version S) or both manually and via an external control device (Version RC)

GEL DRYING. OPTIMUM RESULTS ACHIEVED
THANKS TO CHEMICAL RESISTANCE AND
FULLY VARIABLE VACUUM.

LABOPORT®



CHEMICALLY RESISTANT

N 820.3 FT.18 Diaphragm Vacuum Pump

- Flow rate 1.2 m³/h / Ultimate vacuum 8 mbar abs.
- High level of vapor and condensate compatibility
- PTFE pump head combined with PTFE-coated diaphragm are ideal for extremely aggressive/corrosive gases and vapors

SPEED-CONTROLLED

N 920 KT.29.18 Diaphragm Vacuum Pump

- Flow rate 1.2 m³/h / Ultimate vacuum 2 mbar abs.
- High suction speed, particularly in the low vacuum range
- Integrated rotational speed control enables pumping capacity to be easily adapted to process requirements
- PPS pump head combined with PTFE-coated diaphragm are ideal for aggressive/corrosive gases and vapors

CENTRIFUGAL CONCENTRATION.
PRECISE, HIGH-PERFORMANCE
VACUUM FOR RAPID, GENTLE
TREATMENT OF SAMPLES.



SPEED-CONTROLLED

N 920 KT.29.18 Diaphragm Vacuum Pump

- Flow rate 1.2 m³/h / Ultimate vacuum 2 mbar abs.
- High suction speed, particularly in the low vacuum range
- Integrated rotational speed control enables pumping capacity to be easily adapted to process requirements
- PPS pump head combined with PTFE-coated diaphragm are ideal for aggressive/corrosive gases and vapors

LABOPORT®



CHEMICALLY RESISTANT

N 840.3 FT.18 Diaphragm Vacuum Pump

- Flow rate 2.04 m³/h / Ultimate vacuum 8 mbar abs.
- High level of vapor and condensate compatibility
- PTFE pump head combined with PTFE-coated diaphragm are ideal for extremely aggressive/corrosive gases and vapors



A POWERFUL PACKAGE

N 860.3 FT.40.18 Diaphragm Vacuum Pump

- Flow rate 3.6 m³/h / Ultimate vacuum 4 mbar abs.
- Integrated KNF self-drying system ensures that condensate is quickly removed from the pump heads without the vacuum being altered – processing times are markedly reduced as a result
- Chemically resistant and thus ideal for use with extremely aggressive/corrosive gases and vapors



VACUUM OVEN. OUTSTANDING CHEMICAL AND CONDENSATE COMPATIBILITY WITH FAST EVACUATION OF LARGE VAPOR QUANTITIES.

LABOPORT®



TRIED AND TESTED

N 820.3 FT.40.18 and N 840.3 FT.40.18 Diaphragm Vacuum Pump

- Flow rate up to 2.04 m³/h / Ultimate vacuum 10 mbar abs.
- Integrated KNF self-drying system ensures that condensate is quickly removed from the pump heads without the vacuum being altered – processing times are markedly reduced as a result
- Chemically resistant and thus ideal for use with extremely aggressive/corrosive gases and vapors

A POWERFUL PACKAGE

**N 860.3 FT.40.18 Diaphragm Vacuum Pump**

- Flow rate 3.6 m³/h / Ultimate vacuum 4 mbar abs.
- Integrated KNF self-drying system ensures that condensate is quickly removed from the pump heads without the vacuum being altered – processing times are markedly reduced as a result
- Chemically resistant and thus ideal for use with extremely aggressive/corrosive gases and vapors

MULTI-USER VACUUM SYSTEMS. INEXPENSIVE, SPACE-SAVING SOLUTIONS FOR SUPPLYING VACUUM TO DIFFERENT APPLICATIONS.



QUIET

SC 950 Vacuum Pump System

- Flow rate 3 m³/h / Ultimate vacuum 2 mbar abs.
- Remote-controlled operation for safety when mounted in laboratory furniture
- Automated, precise boiling point recognition and control

LABOBASE®



CONSTANT

SBC 840.40 and SBC 860.40 Vacuum System

- Flow rate up to 3.6 m³/h / Ultimate vacuum up to 4 mbar abs.
- For up to ten users
- Fully-automated vacuum generation system comprising chemically resistant diaphragm vacuum pump, base plate, high-performance condenser, separator, vacuum control device, valves and control unit

TECHNICAL DATA

		LABOPORT® N 86 KT.18	LABOPORT® N 816.3 KT.18	LABOPORT® N 816.1.2 KT.18	LABOPORT® N 938.50 KT.18	N 920 KT.29.18	LABOPORT® N 810.3 FT.18		LABOPORT® N 820.3 FT.18	LABOPORT® N 840.3 FT.18	LABOPORT® N 842.3 FT.18	LABOPORT® SD N 820.3 FT.40.18	LABOPORT® SD N 840.3 FT.40.18	N 860.3 FT.40.18	LABOBASE® SBC 840.40	LABOBASE® SBC 860.40
APPLICATION	Filtration	x	x	x	x					x						
	SPE	x	x		x											
	Degassing		x		x	x			x							
	Fluid aspiration	x	x				x									
	Gel drying					x			x							
	Rotary evaporation					x			x	x	x			x		
	Distillation					x					x			x		
	Vacuum oven											x	x	x		
	Multi-user vacuum systems														x	x
	Centrifugal concentration					x				x				x		
	Metering/Transferring liquids															
TECHNICAL DATA	Flow rate (m³/h) at atm. pressure	0.33	0.96	1.8	1.8	1.2	0.6		1.2	2.04	2.04	1.2	2.04	3.6	2.04	3.6
	Ultimate vacuum (mbar abs.)	160	20	160	15	2	8		8	8	2	10	10	4	10	4
	Operating pressure (bar)	2.5	0.5	0.5	0.5	0.5	1		1	1	1	1	1	1	1	1
	Flow rate (ml/min) with water at 20 °C and zero pressure head															
	Flow rate (l/min) with water at 20 °C and zero pressure head															
	Pressure head (mWg)															
	Suction head (mWg)															
	Connectors for tube (mm)	ID 4	ID 6	ID 6	ID 10	ID 10	ID 10		ID 10	ID 10	ID 10	ID 10	ID 10	ID 12	ID 10	ID 10
	Permissible gas and ambient temperature	+5 ... +40 °C	+5 ... +40 °C	+5 ... +40 °C	+5 ... +40 °C	Gas temp.: + 5 ... +40 °C Ambient temp.: +10 ... +40 °C	+5 ... +40 °C		+5 ... +40 °C	+5 ... +40 °C	+5 ... +40 °C	+5 ... +40 °C	+5 ... +40 °C	+5 ... +40 °C	+5 ... +40 °C	+5 ... +40 °C
	Weight (kg)	1.9	3.95	3.95	6.8	8.6	6.9		9.3	12.6	13.4	9.6	12.9	14.8	22.9	25.3
	Dimensions L x H x W (mm)	164 x 141 x 90	361 x 141 x 90	361 x 141 x 102	317 x 212 x 110	324 x 226 x 158	281 x 187 x 140		312 x 207 x 154	341 x 226 x 166	341 x 223 x 167	312 x 220 x 177	341 x 239 x 189	331 x 278 x 291	450 x 515 x 322	437 x 552 x 314
MATERIAL	Pump head	PPS	PPS	PPS	PPS	PPS	PTFE		PTFE	PTFE	PTFE	PTFE	PTFE	PTFE	PTFE	PTFE
	Diaphragm	PTFE-coated	PTFE-coated	PTFE-coated	PTFE-coated	PTFE-coated	PTFE-coated		PTFE-coated	PTFE-coated	PTFE-coated	PTFE-coated	PTFE-coated	PTFE-coated	PTFE-coated	PTFE-coated
	Valves	FFPM	FFPM	FFPM	FFPM	FFPM	FFPM		FFPM	FFPM	FFPM	FFPM	FFPM	FFPM	FFPM	FFPM
ACCESSORIES	Coolant valve – G 1/2, ID 8														Order no. 045075	Order no. 045075
	Silencer	Order no. 000345	Order no. 000345		Order no. 007006	Order no. 007006										
	Hose connector	G1/8 ID4 PVDF Order no. 025671 G1/8 ID6 PVDF Order no. 123363 G1/8 ID4 PA Order no. 001936 G1/8 ID6 PA Order no. 000360 G1/8 ID8 PA Order no. 004975	G1/8 ID6 PVDF Order no. 123363 G1/8 ID6 PA Order no. 000360 G1/8 ID8 PA Order no. 004975		G1/8 ID10 PVDF Order no. 112004											
	Fine control valve with pressure gauge	Order no. 001786				Order no. 112432										
	Fine control valve with vacuum gauge	Order no. 001787	Order no. 0057830	Order no. 0057830	Order no. 112432											
	Small flange, stainless steel					Order no. 046625										
	Gas washing bottle, 0.5 l														Order no. 045886	Order no. 045886
	Non-return valve - unregulated, for fume hoods (PE-HD)														Order no. 118366 Order no. 118364	Order no. 118366 Order no. 118364
	Vaccum supply point – unregulated, for installation in laboratory equipment (PPS)														Order no. 118362	Order no. 118362
	Mobile controller unit for regulated vacuum supply (chemically-resistant)														Order no. 048459	Order no. 048459

TECHNICAL DATA

		SC 920	SC 950	LABOPORT® SC 820	LABOPORT® SC 840	SIMDOS® 02		SIMDOS® 10	LIQUIPORT® NF 100	LIQUIPORT® NF 300
APPLICATION	Filtration									
	SPE									
	Degassing									
	Fluid aspiration									
	Gel drying									
	Rotary evaporation	x	x	x	x					
	Distillation	x	x							
	Vacuum oven									
	Multi-user vacuum systems		x							
	Centrifugal concentration									
	Metering/Transferring liquids					x		x	x	x
TECHNICAL DATA	Flow rate (m³/h) at atm. pressure	1.2	3.0	1.2	2.04					
	Ultimate vacuum (mbar abs.)	2	2	8	8					
	Operating pressure (bar)			1	1					
	Flow rate (ml/min) with water at 20 °C and zero pressure head					0.03 – 20		1 – 100		
	Flow rate (l/min) with water at 20 °C and zero pressure head								0.2 – 1.3	0.5 – 3.0
	Pressure head (mWg)					60		60	10 (60 with LIQUIPORT® NF 1.100)	10 (60 with LIQUIPORT® NF 1.300)
	Suction head (mWg)					2		3	3	3
	Connectors for tube (mm)	pneumatic: ID 10 coolants: ID 8 inert gas: ID 6	pneumatic: ID 10 coolants: ID 8 inert gas: ID 4	pneumatic: ID 10 coolants: ID 8	pneumatic: ID 10 coolants: ID 8	ID 1.6/AD 3.2		ID 4/AD 6	ID 8	ID 12
	Permissible gas and ambient temperature	+5 ... +40 °C	+5 ... +40 °C	+5 ... +40 °C	+5 ... +40 °C	Ambient temp.: +5 ... +40 °C Liquid temp. +5 ... +80 °C		Ambient temp.: +5 ... +40 °C Liquid temp. +5 ... +80 °C	Ambient temp.: +5 ... +40 °C Liquid temp. +5 ... +80 °C	Ambient temp.: +5 ... +40 °C Liquid temp. +5 ... +80 °C
	Weight (kg)	15.0	14.5	16.0	19.3	0.9		0.9	1.0	1.5
	Dimensions L x H x W (mm)	423 x 366 x 294	487 x 246 x 313	397 x 289 x 506	417 x 289 x 506	130 x 140 x 87		130 x 140 x 87	130 x 99 x 177	160 x 104 x 188
MATERIAL	Pump head	PPS	PPS	PTFE	PTFE	PP, PVDF or PTFE		PP, PVDF or PTFE	PP, PVDF or PTFE	PP, PVDF or PTFE
	Diaphragm	PTFE-coated	PTFE-coated	PTFE-coated	PTFE-coated	PTFE		PTFE	PTFE	PTFE
	Valves	FFPM	FFPM	FFPM	FFPM	FFKM		FFKM	FFKM	FFKM
ACCESSORIES	Coolant valve – G 1/2, ID 8	Order no. 117121	Order no. 117121	Order no. 045075	Order no. 045075					
	Column fixture	for remote control Order no. 120132				Order no. 160474		Order no. 160474	Order no. 160474	Order no. 160474
	Wall fixture	for remote control Order no. 120130				Order no. 160473		Order no. 160473	Order no. 160473	Order no. 160473
	Foot switch for version RC (RC = flow rate can be set both manually and via an external control device)					Order no. 155872		Order no. 155872	Order no. 155872	Order no. 155872
	In-line filters					FS 60 T PVDF Mesh opening 70 µm Order no. 165210 FS 60 X PEEK Mesh opening 35 µm Order no. 165212		FS 25 T PVDF Mesh opening 70 µm Order no. 165211 FS 25 X PEEK Mesh opening 35 µm Order no. 165213		



		RC 900	C 900
TECHNICAL DATA	APPLICATION		
	Rotary evaporation	x	x
	Heating bath: Heating bath temperature (°C)	20 – 180	
	Working temperature range (°C)		-10 – +40
	Coolant supply parameters (condenser): - Permissible pressure (bar) - Permissible temperature - Coolant-coated surface (cm²)	3 -15 °C – +20 °C 1230	
	Cooling capacity (W)		250
	Parameters of evaporation flask: - Size of evaporation flask - Rotational speed of evaporation flask (1/min) - Length of stroke (mm) - Lifting speed (mm/s)	50 – 4000 ml 25 – 250 150 ca. 38	
	Temperature stability (°C)		± 0.5
	Filling volume (l)		1.7 – 2.6
	Cooling agent		R134a
	Temperature control		PID temperature control
ACCESSORIES	Weight (kg)	9.1	27
	Dimensions L x H x W (mm) - without glass (footprint) - with glass	- 447 x 464 x 431 447 x 823 x 487	235 x 520 x 400 - -
	Protective cover heating bath	Order no. 127204	
	Refill valve	Order no. 300639	
	Coolant valve	Order no. 300853	
	Collection flask (implosion protected): - 100 ml - 250 ml - 500 ml - 1000 ml - 2000 ml	Order no. 300557 Order no. 300558 Order no. 128158 Order no. 113939 Order no. 113938	
	Evaporation flask NS29/32: - 50 ml - 100 ml - 250 ml - 500 ml - 1000 ml - 2000 ml - 3000 ml	Order no. 113079 Order no. 113080 Order no. 113081 Order no. 113082 Order no. 128159 Order no. 113083 Order no. 113084	
	Evaporation flask NS24/40: - 50 ml - 100 ml - 250 ml - 500 ml - 1000 ml - 2000 ml - 3000 ml	Order no. 300561 Order no. 300562 Order no. 300563 Order no. 300564 Order no. 128893 Order no. 300565 Order no. 300566	
	Vapor tube NS29/32: - 500 ml - 1000 ml - 2000 ml	Order no. 300588 Order no. 300589 Order no. 300590	
	Vapor tube NS24/40: - 500 ml - 1000 ml - 2000 ml	Order no. 300591 Order no. 300592 Order no. 300593	
	Foam brake NS29/32	Order no. 301114	
	Foam brake NS24/40	Order no. 301115	

KNF offers a wide range of high-quality pumps and systems for moving both liquids and gases. Whether they are used as built-in OEM pumps, in process applications or in laboratories, KNF products offer high performance, precision, and reliability. We offer all of our customers expert and personal advice. Contact us today to discuss how we can assist you with your next project!

The KNF production sites worldwide:



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